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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/233,377
Filing Date January 18, 1999
Inventor Gurtej S. Sandhu et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner T. Pham
Attorney's Docket No. MI22-1114
Title: Method of Forming a Refractory Metal Silicide (as Amended)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and articles listed on the attached Form PTO-1449. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: Aug. 30, 2002

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